

09/28/2009

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Yasuo FUKUDA et al.                      Group Art Unit : 1792  
Appl. No. : 10/596,280                                      Examiner : G. Nagesh RAO  
Filed : June 8, 2006    Confirmation No. : 4880  
For : EPITAXIAL WAFER AND METHOD FOR PRODUCING SAME

**AMENDMENT AFTER FINAL REJECTION UNDER 37 C.F.R. § 1.116  
AND RECORD OF TELEPHONIC INTERVIEW**

Commissioner for Patents  
U.S. Patent and Trademark Office  
Customer Service Window, Mail Stop **AF**  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir:

This Amendment is responsive to the Final Office Action mailed June 25, 2009 and is pursuant to an August 20, 2009 telephonic interview with Examiner G. Nagesh Rao, and the August 26, 2009 Examiner Interview Summary. Applicants respectfully request reconsideration and withdrawal of each of the rejections of the outstanding Office Action, and request allowance of all the claims pending herein. Inasmuch as the three-month shortened statutory period is set in the Office Action to expire on September 25, 2009, this response is being filed in a timely manner and no additional fee or extension of time is deemed necessary. Should any extension of time or fees be required to maintain pendency of the application, however, the same is hereby requested and authorization is hereby provided to charge any fees to Deposit Account No. 19-0089.

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks** begin on page 5 of this paper.